



Novel and Diverse Applications of Silicon Nanosensors and Imagers

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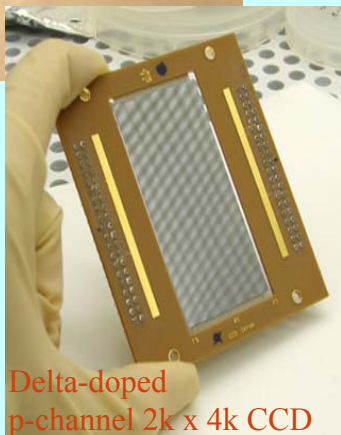
Advanced Detector Arrays and Nanoscience Group

Cylindrically curved CCD

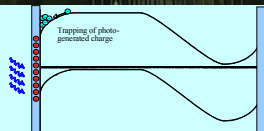
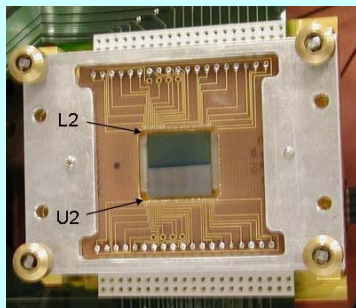
Back illuminated Si UV/Vis/NIR Imagers

Particle Detectors

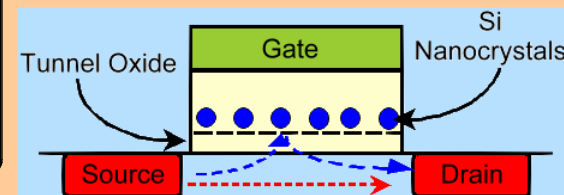
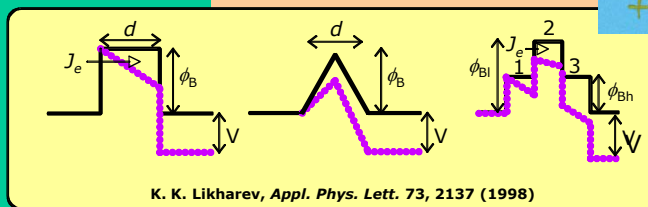
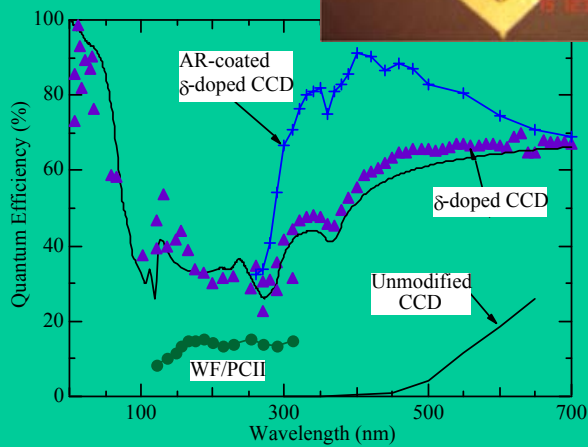
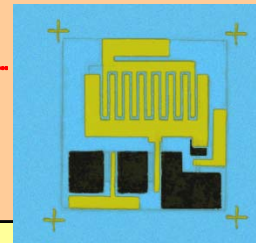
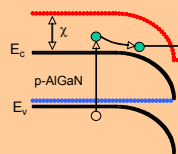
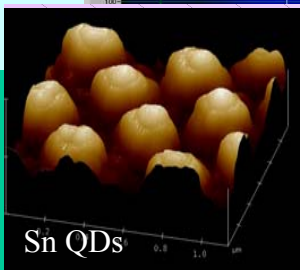
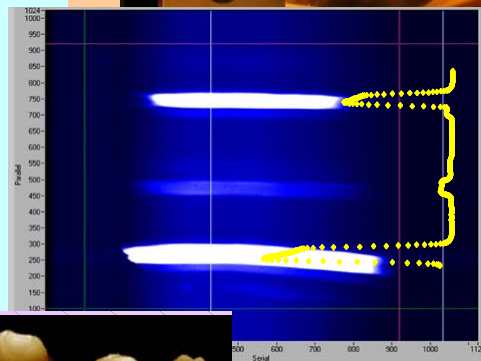
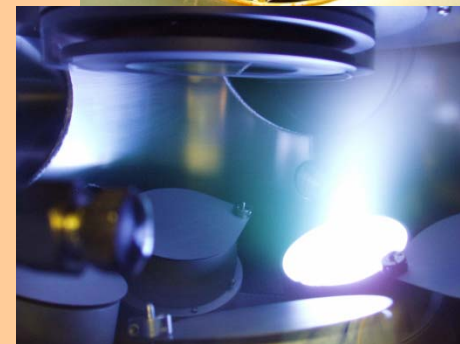
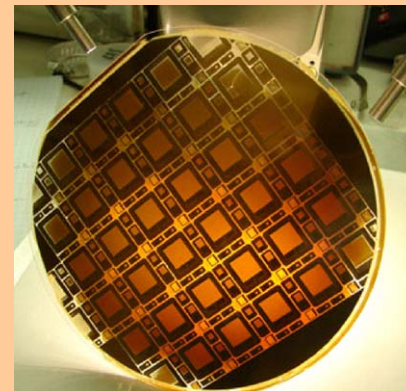
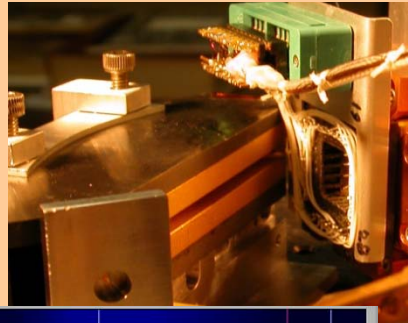
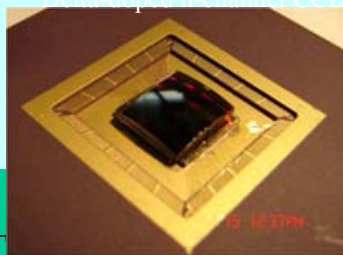
End-to-end Processing



Delta-doped p-channel 2k x 4k CCD

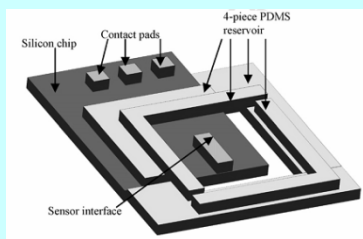
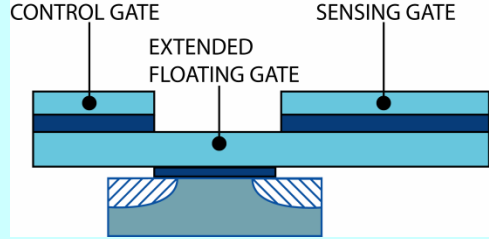


Delta-doped n-channel CCD

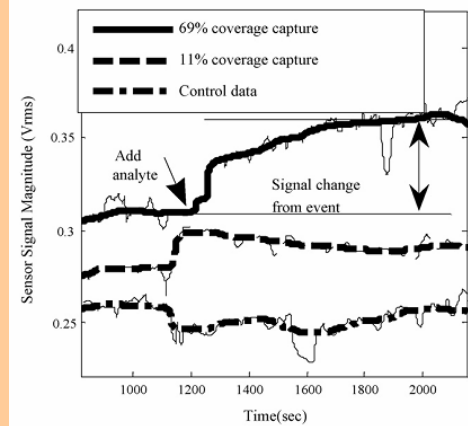


CvMOS: Charge-based sensors

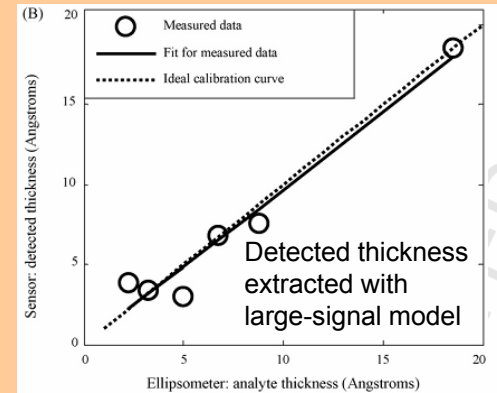
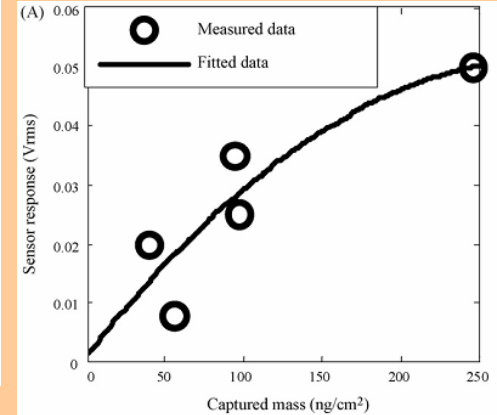
CMOS-Based Biosensors



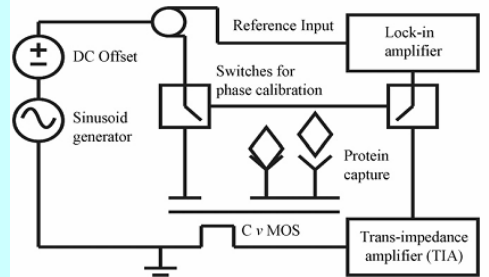
Real-Time Detection



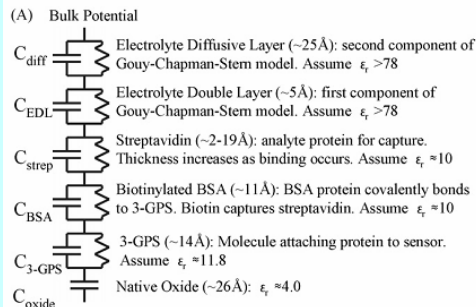
Calibration Curves



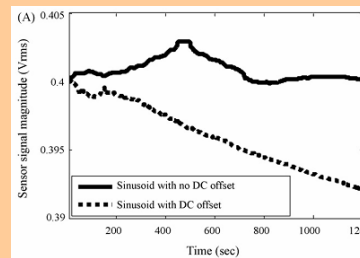
Measurement of Protein Binding



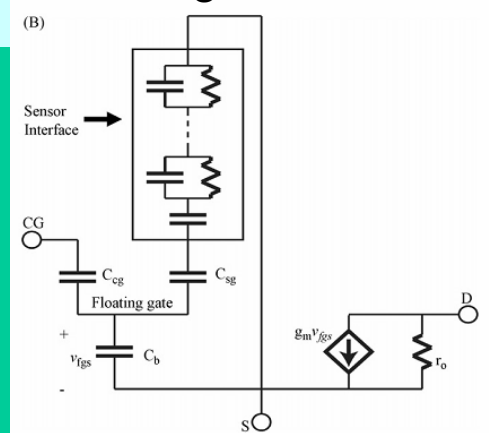
Impedance Model



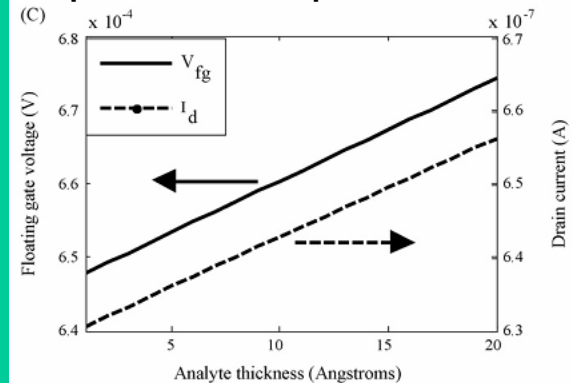
Low drift



Small-Signal Model



Expected Response



- Detection limit: 25 ng/cm² or 2Å
- 1.5μm technology scaled down
- Different materials to block mobile ions

